



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re application of: FAN

Attorney Docket No.: KLA1P118/P1062

Application No.: 10/600,500

Examiner: STEVENSON, Andre C.

Filed: June 19, 2003

Group: 2812

Title: METHOD AND APPARATUS FOR

REVIEWING VOLTAGE CONTRAST DEFECTS

IN SEMICONDUCTOR WAFERS

Confirmation No.: 6747

**CERTIFICATE OF MAILING** 

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on July 14, 2005 in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signed:

Sue Funchess

## **REQUEST FOR STATUS**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant hereby requests status of the above-referenced patent application. A response to the non-final office action was filed on September 29, 2004, and no response has been received as of this date.

Respectfully submitted,

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